

DO NOT ENTER: /R.H./

01/14/2010

**EXPEDITED PROCEDURE**  
**Examining Group Number 4146**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Werner Ertle et al.	Examiner:	Robert T. Huber
Serial No.:	10/522,502	Group Art Unit:	4146
Filed:	November 11, 2005	Docket No.:	I431.124.101/FIN404PCT/US
Title:	SEMICONDUCTOR WAFER WITH ELECTRICALLY CONNECTED CONTACT AND TEST AREAS		

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**AMENDMENT AND RESPONSE UNDER 37 C.F.R. 1.116**

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This Amendment and Response is in reply to the Final Office Action mailed November 10, 2009. Please amend the above-identified patent application as follows: